Atty. Docket No.: 034299-626



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PPLICANT:

Gerard Petroz

**SERIAL NO.:** 

10/528,436

**CONFIRMATION NO.:** 

4303

FILING DATE:

March 18, 2005

TITLE:

Method For The Production Of Electrodes On A Type II Or VI

Semiconductor Material Or On A Compound Of Said Material

**EXAMINER:** 

Pham, Thanhha S.

ART UNIT:

2813

## **CERTIFICATE OF MAILING**

I hereby certify that this paper is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria VA 22313-1450, on the date printed below:

Date:

10/22/07

Name:

Monica Pizarro

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## AMENDMENT AND/OR RESPONSE TO OFFICE ACTION

Sir:

In response to the Office Action mailed June 22, 2007, please amend the subject application as indicated.

Amendments to the Claims, if any, are reflected in the Listing of Claims beginning on page 2.

Remarks begin on page 4.